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Date:	1 0							
	Au	August 13, 2004						
To;	US	US Patent & Trademark Office Fax: 703-872-9306						
From:	Da	David E. Steuber Tel: 408/982-8201 Fax: 408/982-8210						
Pages	9 (including cover sheet)							
Inventors:		William R. Entley et al.						
Title:		In Situ Plasma Process To Remove Fluorine Residues From The Interior Surfaces Of A CVD Reactor						
Application		10/003,908	Confirmation	7739				
Examiner:		Anita Karen Alanko						

Enclosed for filing in the above-identified application are the following:

Transmittal Letter (1 page); and Amendment After Final (7 pages)

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TRANSMITTAL			Application Number	10/003,908				
	ORM	.	Filing Date	11/1/2001				
			First Named Inventor	William R. Entley				
			Group Art Unit	1765				
(to be used for all co	orrespondence after ini	itial filing)	Examiner Name	Anita Karen Alanko				
Total Number Of Pages In This Submission 8			Attorney Docket No.	NVS013 US				
ENCLOSURES (check all the								
Fee Transmittal duplicate)	Form (1 page in	Aşş	ignment Papers	After Allowance Communication to				
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Amendment Rep	form (1 page)		ving(s)	Appeal Communication to Board of Appeals and Interferences				
		Lice	nsing-related Papers	Appeal Communication to Group (Appeal Notice, Briof, Reply Brief)				
After Fina	il (7 pages)	Petit	ion	Proprietary Information				
Affidavits/	declarations	Petit	ion to Convert to a					
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Extension of Time	Request	r rev	ous Powers; And Statement or 37 CFR 3.73(b)	Other Enclosure(s) (please identify below):				
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Firm or	David E. Steube	r (Reg. No	. 25,557)	· SICHOLNI				
Individual Name Silicon Valley Patent Grou		tent Group	LLP					
2350 Mission College Boule			evard, Suite 360					
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Signature Rand 2			Studen					
Date August 13, 2004								
CERTIFICATE OF F. I hereby certify that this number 703-872-9306, o	correspondence is bon August 13, 2004	SMISSION poing facsim	ile transmitted to the U.S	. Patent and Trademark Office to the fax				
Attorney for Applic	Cant(s) Date of Si	•	7					
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.

10/003,908

Confirmation No.

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First Inventor

William R. Entley

Filing Date

11/1/2001

Tech. Center/ Art Unit

1765

Examiner

Anita Karen Alanko

Title:

In Situ Plasma Process To Remove Fluorine Residues From The

Interior Surfaces Of A CVD Reactor

Docket No.:

NV\$013 US

Customer No.:

34036

Santa Clara, California August 13, 2004

MAIL STOP AF COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL ACTION

Dear Sir:

In response to Office Action dated May 19, 2004, please amend the aboveidentified application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.